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APPLICANTS

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** CONTINUING DATA *****

No n.

** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 2002-48720 08/17/2002

verified. *EP*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature	<i>EP</i>	Initials	15	26	4

ADDRESS

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TITLE

Method of forming oxide layer using atomic layer deposition method and method of forming capacitor of semiconductor device using the same

<input type="checkbox"/> All Fees
<input checked="" type="checkbox"/> 1.16 Fees (Filing)